Electronic Acknowledgement Receipt				
EFS ID:	3580023			
Application Number:	10511883			
International Application Number:				
Confirmation Number:	4213			
Title of Invention:	Apparatus and method for depositing thin film on wafer using remot plasma			
First Named Inventor/Applicant Name:	Young Hoon Park			
Customer Number:	23413			
Filer:	James J. Merrick			
Filer Authorized By:				
Attorney Docket Number:	YPL-0108			
Receipt Date:	08-JUL-2008			
Filing Date:	19-OCT-2004			
Time Stamp:	13:05:26			
Application Type:	U.S. National Stage under 35 USC 371			

Payment information:

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Payment Type	Deposit Account
Payment was successfully received in RAM	\$1050
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File Listing:								
Document Number	Document Description	File Name	File Size(Bytes) /Message Digest	Multi Part /.zip	Pages (if appl.)			
1 Amendment - After Non-Final Rejection	23E0496.PDF	171477	no	13				
		d0e255cc3a8f8e7affec90527fd5e0777 1 ed4566						
Warnings:								
Information:		_						
2 Fee Worksheet (PTO-06)	fee-info.pdf	8187		2				
		a95747d363f9b3b9a33b0af10f16fe626f be1935	no					
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If a timely submission to enter the national stage of an international application is compliant with the conditions of 35 U.S.C. 371 and other applicable requirements a Form PCT/DO/EO/903 indicating acceptance of the application as a national stage submission under 35 U.S.C. 371 will be issued in addition to the Filing Receipt, in due course.

New International Application Filed with the USPTO as a Receiving Office

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